



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

LG835654985
Report verification at igi.org

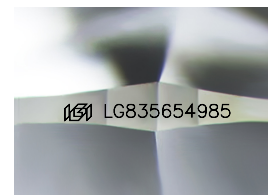
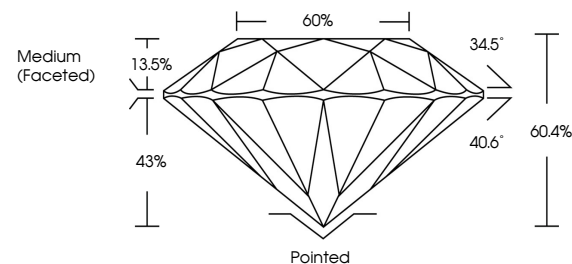
September 15, 2026	
IGI Report Number	LG835654985
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	ROUND BRILLIANT
Measurements	8.23 - 8.25 X 4.98 MM
GRADING RESULTS	
Carat Weight	2.09 CARATS
Color Grade	E
Clarity Grade	VVS 2
Cut Grade	IDEAL

ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	 LG835654985

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

PROPORTIONS



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

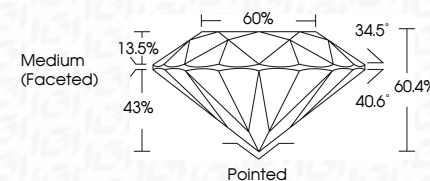
CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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www.igi.org

September 15, 2026
ICI Report No LG835654985
ROUND BRILLIANT

8.23 - 8.25 X 4.95 MM	Carat Weight	2.09 CARATS
	Color Grade	E
	Clarity Grade	VVS 2
	Cut Grade	IDEAL
	Depth	60.4%
	Table	60%
	Girdle	Medium (Faceted)
	Culet	Pointed
	Polish	EXCELLENT
	Symmetry	EXCELLENT
	Fluorescence	NONE
	Inspection	gem1 carat/size/shape

Comments:
This Laboratory Grown Diamond was
created by Chemical Vapor Deposition
(CVD) growth process.